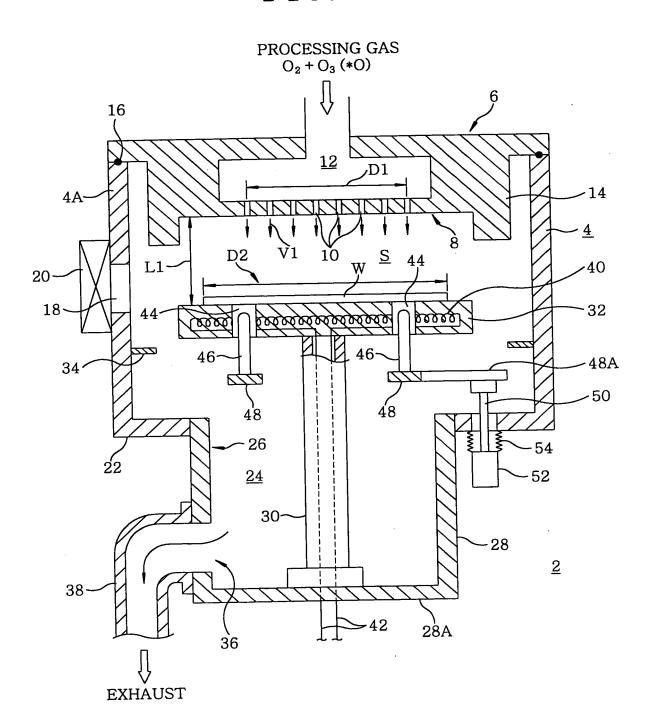
## FIG. 1

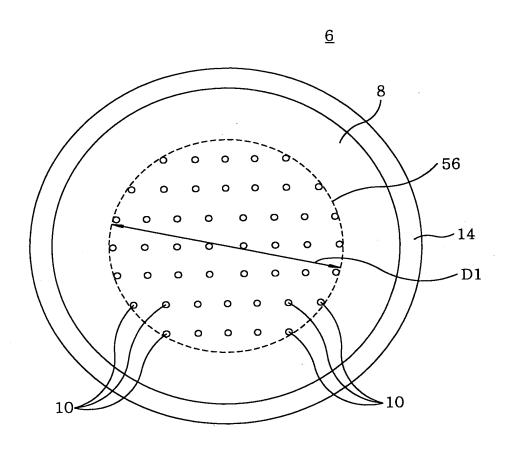


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FIG.2



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GAS JETTING VELOCITY V1 (m/sec)

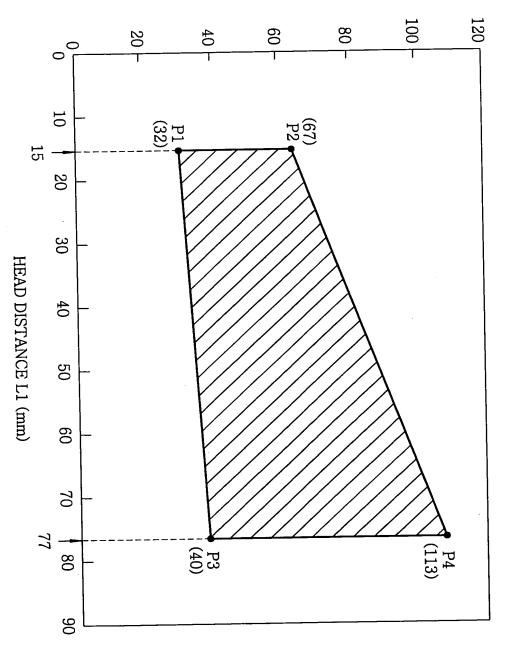
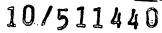


FIG.3



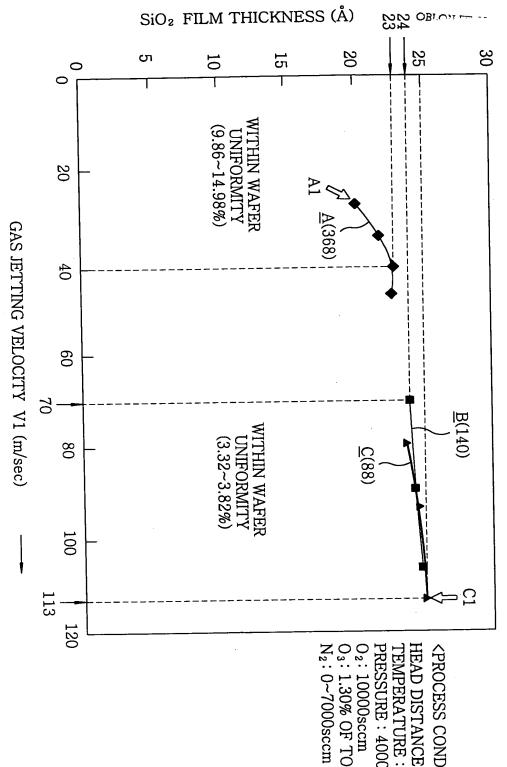


FIG.4

HEAD DISTANCE L1:77mm TEMPERATURE:660°C PRESSURE:4000Pa <PROCESS CONDITION>

0<sub>2</sub>: 10000sccm 0<sub>3</sub>: 1.30% OF TOTAL FLOW RATE

SiO<sub>2</sub> FILM THICKNESS (Å)

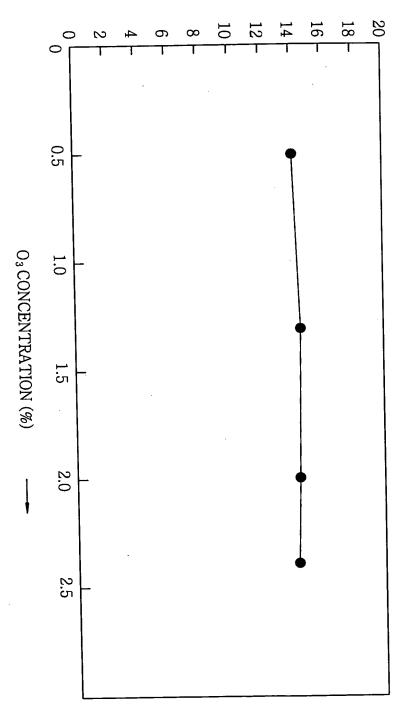
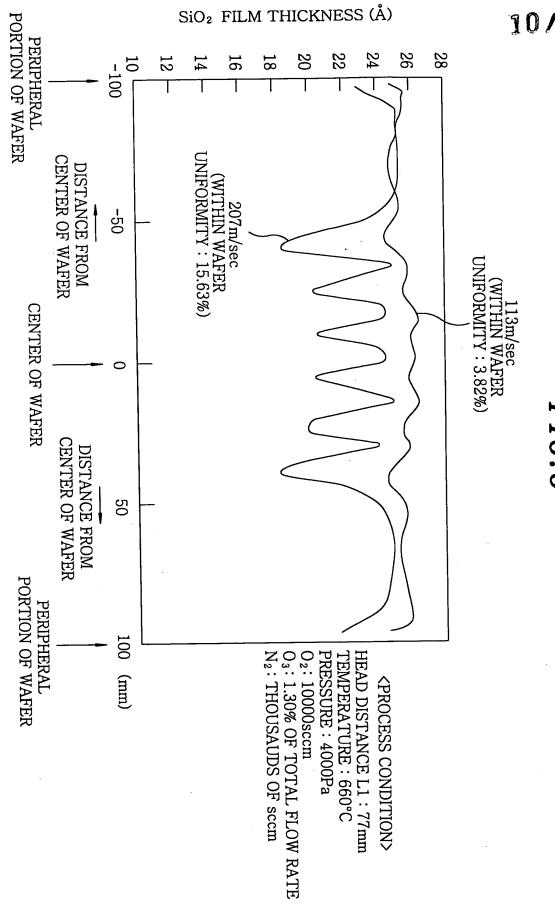


FIG.5



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FIG.7A

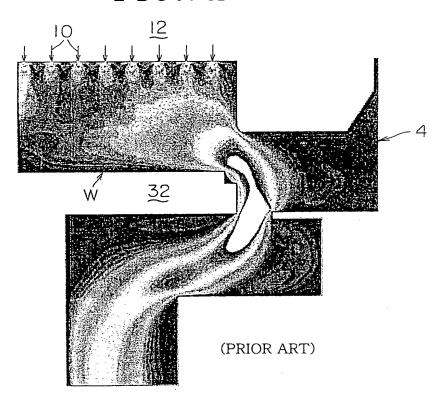
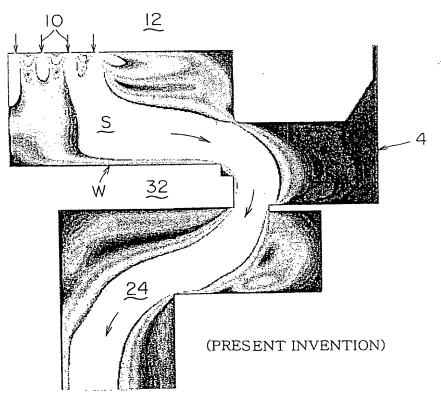


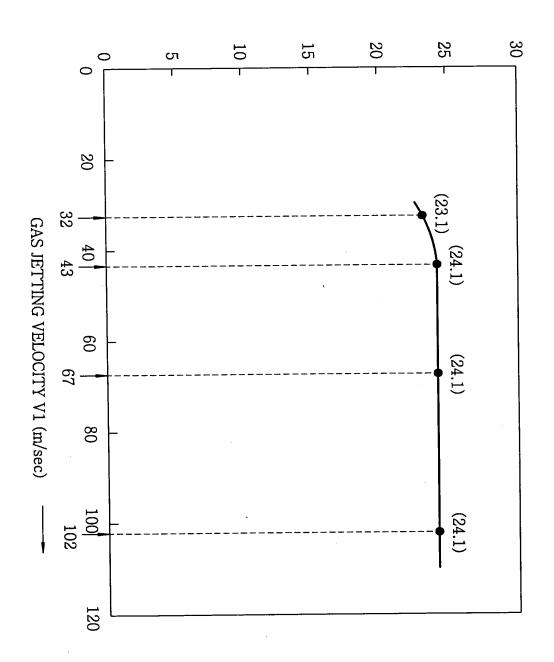
FIG.7B



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SiO<sub>2</sub> FILM THICKNESS (Å)



7IC.8

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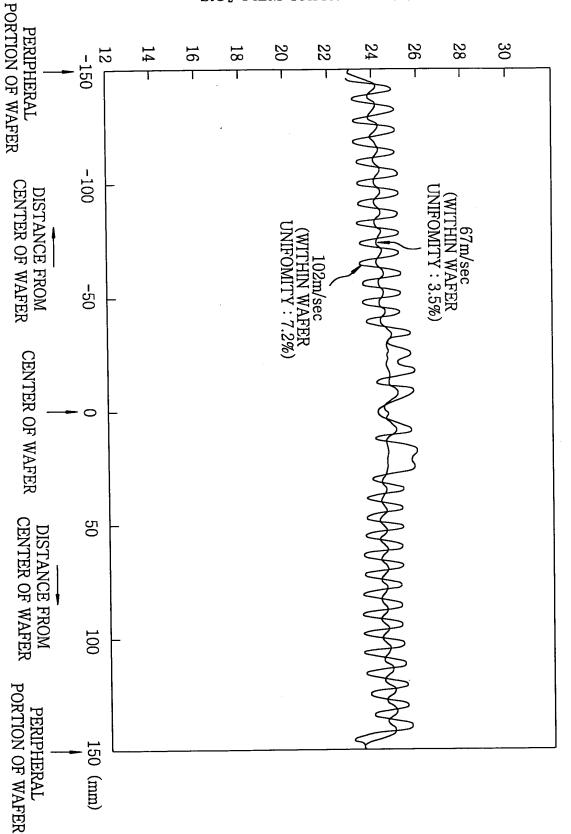


FIG.9